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500.41374CX2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: KANNO et al

Serial No.: 10/658,281

Filed: September 10, 2003

For: Wafer Stage For Wafer Processing Apparatus
And Wafer Processing Method

Art Unit: 3742

Examiner: S. Fuqua

AMENDMENT

Mail Stop: Amendment (Fee)
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

January 5, 2006

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application with the accompanying RCE, in response to the Office Action dated October 5, 2005. The amendments are listed below and set forth on the following pages.

Amendments to the Claims; and

Remarks are included following the amendments.